

AF1 JFW

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Ju-Cheol SHIN et al.

Docket No.

SEC.828D

Application No.

10/601,561

Filing Date

June 24, 2003

Examiner

Karla A. Moore

Customer No.

20987

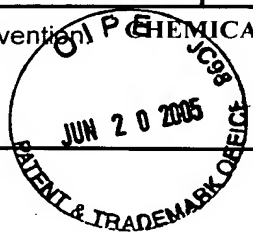
Group Art Unit

1763

Confirmation No.

7739

Invention: **CHEMICAL VAPOR DEPOSITION APPARATUS FOR DEPOSITING SILICIDE**



COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

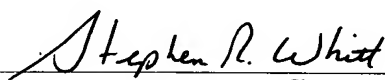
The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	7 -	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
- ☐ A check in the amount of _____ to cover the filing fee is enclosed.
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Dated: JUNE 20, 2005

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Application No. 10/601,561
Attorney Docket No. SEC.828D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Ju-Cheol Shin et al. : Group Art Unit: 1763
Application No. 10/601,561 : Examiner Karla A. Moore
Filed: June 24, 2003 :
Title: CHEMICAL VAPOR DEPOSITION APPARATUS FOR DEPOSITING
SILICIDE

AMENDMENT AFTER FINAL

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop AF
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir or Madam:

In response to the Office Action of May 9, 2005, please amend the
application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.